



PATENT  
8045-1015

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Shinichi NAKATA et al.

Conf. 6017

Application No. 10/676,132

Group 1725

Filed October 2, 2003

Examiner Maria A. Elve

MASK FOR LIGHT EXPOSURE AND METHOD  
FOR MANUFACTURING LIQUID CRYSTAL  
DISPLAY APPARATUS EMPLOYING SAME

AMENDMENT

MS AMENDMENT

Commissioner for Patents

April 8, 2005

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action of March 17, 2005,  
please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing  
of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.